

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/579,777 Confirmation No. : 5716  
First Named Inventor : Hiraku ISHIKAWA  
Filed : February 26, 3008  
TC/A.U. : 1792  
Examiner : Shamim Ahmed  
  
Docket No. : 101994.57726US  
Customer No. : 23911  
  
Title : Plasma Film-Forming Apparatus and Plasma Film-  
Forming Method

**REPLY TO OFFICE ACTION**

**Mail Stop AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the Office Action dated October 27, 2008.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. *No additional claims fees are due.*

**Remarks** begin on page 5 of this paper.